

ABSTRACT

In order to efficiently remove deposited material adhering to the interior of an abatement device, an abatement device (4) is equipped with a deposited material removing means (40) for removing deposited material (17) produced during abatement of exhaust gas.

- 5 The deposited material removing means includes: a storage unit (P3) that stores a liquid; a gas supply unit (P1) that supplies pressurized gas to the storage unit; and a valve (41) that sprays a mixed fluid of the liquid stored in the storage unit and the gas supplied by the gas supply unit.

10 Figure No. 3